

RECEIVED
CENTRAL FAX CENTER

JAN 26 2007

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Applicant:	Randy Skocypec et al.	§	Art Unit:	1746
Serial No.:	10/622,307	§	Examiner:	Bibi Sharidan Carrillo
Filed:	July 18, 2003	§	Docket:	ITL1017US P16704
For:	Cleaning Semiconductor Wafers	§	Assignee:	Intel Corporation

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REPLY TO FINAL REJECTION

Sir:

In response to the final rejection mailed January 11, 2007, reconsideration is requested in view of the following remarks.

A current listing of the claims is attached. No amendments were made.

off to
Guber
1/28/07

Date of Report: January 26, 2007

I hereby certify that this document is being facsimile transmitted to the
United States Patent and Trademark Office (Fax No. 571/293-6300) on the
date indicated above.

Cynthia L. Hayden
Cynthia L. Hayden